



S/N 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Trung T. Doan	Examiner:	Sylvia MacArthur
Serial No.:	09/652,713	Group Art Unit:	1763
Filed:	August 31, 2000	Docket No:	303.928US5
Title	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING		

PETITION FOR A TWO-MONTH EXTENSION OF TIME

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a two-month extension of time be granted in which to respond to the Office Action mailed August 19, 2005, said period of response being extended from November 19, 2005 to January 19, 2006.

**Our check in the amount of \$450.00 is enclosed to cover the required extension fee.**  
**Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.**

Respectfully Submitted

TRUNG T. DOAN

By his Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A  
P.O. Box 2938  
Minneapolis, MN 55402  
(612) 349-9587

01/20/2006 SHASSEN1 00000007 09652713  
02 FC:1252 450.00 0P

Date: 17 Jan '06 By: [Signature]  
Timothy B. Clise  
Reg. No: 40,957

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 17 day of January 2006.

Name: KATE GANNON Signature: [Signature]